



2822  
IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MANABU TOMITA ET AL.

Serial No. 09/387,477 (TIJ-26105)

Filed September 1, 1999

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Art Unit 2822

Examiner M. Guerrero

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

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11-30-04

Jay M. Cantor, Reg. No. 19,906

Sir:

**AMENDMENT UNDER 37 C.F.R. 1.111**

In response to the Office action dated October 19, 2004, please amend the above-identified application as follows: